

DEC 27 2002

ASMEX.367A

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE JAN -2 2003

TECHNOLOGY CENTER 2800

Applicant : Todd, Michael A.

Appl. No. : 10/074,534

Filed : February 11, 2002

For : PROCESS FOR DEPOSITION  
OF SEMICONDUCTOR FILMS

Examiner : Trinh, Hoa B.

) Group Art Unit 2814

)

) I hereby certify that this correspondence  
) and all marked attachments are being  
) deposited with the United States Postal  
) Service as first class mail in an envelope  
) addressed to: United States Patent and  
) Trademark Office, P.O. Box 2327,  
) Arlington, VA 22202, on:

December 20, 2002

(Date)

Joseph J. Mallon, Reg. No. 39,287

RESPONSE TO RESTRICTION REQUIREMENT

United States Patent and Trademark Office  
P.O. Box 2327  
Arlington, VA 22202

Dear Sir:

Applicants have received the Office Action of December 4, 2002. Claims 1-33 are currently pending in this application. Since this response is being transmitted to the Office on December 20, 2002, this response is timely filed.

The Office requires restriction to one of the following groups:

Group I: Claims 1-15, 20-33, drawn to a method, classified in class 438, subclass 222.

Group II: Claims 16-19, drawn to a device, classified in class 257, subclass 55+

In response, Applicants hereby elect Group I, Claims 1-15 and 20-33, without traverse, for further prosecution on the merits, and understand that Group II, Claims 16-19, will be withdrawn as being directed to a non-elected invention. Applicants reserve the right to file divisional and/or continuation applications containing claims directed to all or part of the subject

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matter of any claims amended, withdrawn, or canceled at any time during the prosecution of this application, and thus unclaimed subject matter is not dedicated to the public.

Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 12/20/02

By: Joseph J. Mallon  
Joseph J. Mallon  
Registration No. 39,287  
Attorney of Record  
Customer No. 20,995  
(619) 235-8550

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PATENT

Case Docket No. ASMEX.367A

Date: December 20, 2002

Page 1

In re application of : Michael A. Todd  
App. No. : 10/074,534  
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*Joseph J. Mallon*  
Joseph J. Mallon, Reg. No. 39,287

UNITED STATES PATENT AND TRADEMARK OFFICE  
P.O. Box 2327  
Arlington, VA 22202

Sir: Transmitted herewith is a Response to Restriction Requirement in the above-identified application.

The fee has been calculated as shown below:

CLAIMS AS FILED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	28	33	= 0	\$9	= \$0
Independent Claims	2	3	= 0	\$42	= \$0
If application has been amended to contain multiple dependent claim(s), then add				\$140	= \$0
Time Extension Fee					\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

(X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

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